

Aug-05-04 02:58pm From-Moser, Patterson & Sheridan L.L.P.

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PATENT  
Atty. Dkt. No. AMAT/5618/DSM/LOW K/JW

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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
Nguyen, et al.

Serial No.: 09/912,103

Confirmation No.: 4476

Filed: July 23, 2001

**For: Selective Etching of  
Organosilicate Films Over  
Silicon Oxide Stop Etch Layers**

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Group Art Unit: 2823

**Examiner: Khiem D. Nguyen**

**MAIL STOP**  
**Commissioner for Patents**  
**P.O. Box 1450**  
**Alexandria, VA 22313-1450**

Dear Sir:

**CERTIFICATE OF FACSIMILE  
TRANSMISSION UNDER 37 CFR 1.8**

## **RESPONSE TO OFFICE ACTION DATED JULY 2, 2003**

In response to the Office Action dated July 2, 2003, having a shortened statutory period for response set to expire on October 2, 2003, please enter this response and reconsider the claims pending in the application for reasons discussed below. The Commissioner is hereby authorized to charge counsel's Deposit Account No. 20-0782/AMAT/5619/BTP, the fee of \$72.00 for four additional dependent claims, and any other fees, including extension of time fees, required to make this Response timely and acceptable to the Office.

MOSER  
PATTERSON &  
SHERIDAN, LLP

ATTORNEYS AT LAW

3040 Post Oak Blvd, Suite 1500  
Houston, TX 77056-6582  
TEL 713.623.4844  
FAX 713.623.4846  
[www.MPSLLP.COM](http://www.MPSLLP.COM)

## FACSIMILE COVER SHEET

**DATE:** August 5, 2004  
**FILE NO.:** AMAT/5619/DSM/LOW K/JW  
**TO:** Examiner Khiem D. Nguyen  
**FAX NO.:** 571-273-1865  
**PHONE NO.:** 571-272-1865  
**COMPANY:** USPTO  
**FROM:** Keith M. Tackett  
**PAGE(S) with cover:** 11

**ORIGINAL TO FOLLOW?**  YES  NO

**MESSAGE:** Attached are copies of the Response to Office Action dated July 2, 2003; Facsimile Cover Sheet; and Confirmation Facsimile Transmittal filed on October 2, 2003, which was faxed to the designated fax number 703-746-9179 from the Office Action dated February 14, 2003.

### RESPONSE TO OFFICE ACTION DATED JULY 2, 2003

**TITLE:** SELECTIVE ETCHING OF ORGANOSILICATE FILMS OVER  
SILICON OXIDE STOP ETCH LAYERS  
**U.S. SERIAL NO.:** 09/912,103  
**FILING DATE:** JULY 23, 2001  
**INVENTOR:** NGUYEN, ET AL.  
**EXAMINER:** KHIEM D. NGUYEN  
**GROUP ART UNIT:** 2823  
**CONFIRMATION NO.:** 4476

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